



Call for paper

International Workshop on Piezoelectric Materials and Applications in Actuators

IWPMA2018

September 11-14, KOBE, Japan

Important dates

Abstract Submission Open	February 1, 2018
Abstract Submission Due	June 10, 2018
Notice of Acceptance	July 10, 2018
Pre-registration Due	July 20, 2018

(Expected)

Contact us

web: <http://www.iwpma2018.org/>

e-mail: contact@iwpma2018.org

IWPMA2018

International Workshop on Piezoelectric Materials and Applications in Actuators (IWPMA2018)

September 11 - 14, 2018, Kobe, JAPAN

Organized by Committee for Next Generation Sensors and Actuators, The Japan Society for Precision Engineering (JSPE)

Committees

Organizing Committee

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Piotr Vasiljev (Lithuania)

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Sergejus Borodinas (Lithuania)

Focus Topics

New Energy Technology

Sustainability Technology/Pb-Free Piezoelectrics

Piezoelectric Single Crystal

Piezoelectric/Magnetostrictive/Shape Memory Materials,

Manufacturing Process, Characterization Methods

Piezoelectric Motors, Transformers

Multiferroic and Composite Sensors/Actuators

Other Solid State Actuators (Bio, MR, ER, Chemical)

Compact Electromagnetic Motors and Devices

MEMS Devices (Actuators and Sensors)

Smart Structures and Systems with Actuators and Sensors

Ultrasonic Technologies

Drive Circuits for Actuators/Sensors

Integrated/Hybrid Systems of Actuators and Sensors

Exhibition

Spaces are open for exhibition of samples and devices. Industrial firms are encouraged to take the opportunity to display your relevant products. Please contact the Secretariat.

Important Dates

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Pre-registration due: July 20, 2018

Conference Time Table

Date	Morning	Afternoon	Evening
September 11, 2018 Tuesday	-	Registration	Welcome Reception
September 12, 2018 Wednesday	Opening ceremony Technical Session	Technical Session	-
September 13, 2018 Thursday	Technical Session	Technical Session	Banquet
September 14, 2018 Friday	Technical Session	Technical Session	-

Registration fee

Payment of registration fees can be made by credit card, or bank transfer.

	Early Registration (Until Jul. 20, 2018)	Late Registration (After Jul. 20, 2018)	On-site Registration (Sep. 11-14, 2018)
Regular participant	JPY 50,000	JPY 60,000	JPY 60,000
Student	JPY 30,000	JPY 40,000	JPY 40,000

In the following process, "Registration Fee" can be paid ONLY by credit card. If you have difficulty on the payment, please contact us.

Cancel Policy

Until Jun. 20, 2018, 50% of paid fee can be refunded on cancellation. After Jun. 20, 2018, paid fee is not refundable.

Website

<http://www.iwpma2018.org/topics.php>